

INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

May 29, 2025

IGI Report Number

DESCRIPTION

SHAPE AND CUTTING STYLE

MEASUREMENTS

LG696530247

LABORATORY GROWN DIAMOND

EMERALD CUT

7.71 X 5.30 X 3.60 MM

GRADING RESULTS

CARAT WEIGHT

COLOR GRADE

CLARITY GRADE

1.53 CARAT

D

VVS 2

ADDITIONAL GRADING INFORMATION

POLISH

SYMMETRY

FLUORESCENCE

EXCELLENT

EXCELLENT

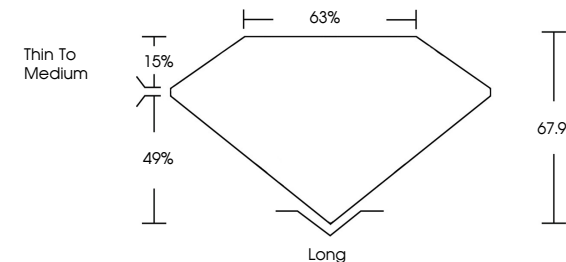
NONE

INSCRIPTION(S)

COMMENTS: THIS LABORATORY GROWN DIAMOND WAS CREATED BY CHEMICAL VAPOR DEPOSITION (CVD) GROWTH PROCESS. TYPE IIA

IGI LG696530247

PROPORTIONS



THIN TO MEDIUM

63%

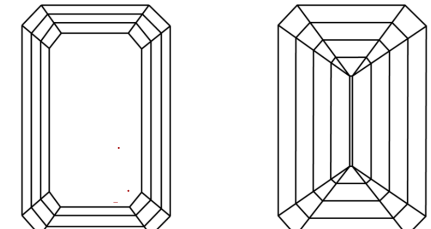
15%

49%

67.9%

LONG

CLARITY CHARACTERISTICS




KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

LG696530247

Report verification at igi.org

Sample Image Used



COLOR

D

E

F

G

H

I

J

Faint

Very Light

Light

CLARITY

IF

VS¹⁻²

VS¹⁻²

SI¹⁻²

I¹⁻³

Internally Flawless

Very Very Slightly Included



Very Slightly Included

Slightly Included

Included

© IGI 2020, International Gemological Institute

FD - 10 20



LABORATORY GROWN DIAMOND REPORT



May 29, 2025

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG696530247

LABORATORY GROWN DIAMOND

EMERALD CUT

7.71 X 5.30 X 3.60 MM

GRADING RESULTS

CARAT WEIGHT

COLOR GRADE

CLARITY GRADE

1.53 CARAT

D

VVS 2

ADDITIONAL GRADING INFORMATION

POLISH

SYMMETRY

FLUORESCENCE

EXCELLENT

EXCELLENT

NONE

INSCRIPTION(S)

COMMENTS: THIS LABORATORY GROWN DIAMOND WAS CREATED BY CHEMICAL VAPOR DEPOSITION (CVD) GROWTH PROCESS. TYPE IIA

IGI LG696530247



IGI

May 29, 2025

IGI Report No LG696530247

EMERALD CUT

7.71 X 5.30 X 3.60 MM

CARAT WEIGHT

COLOR GRADE

CLARITY GRADE

DEPTH

TABLE

GRADE

THIN TO MEDIUM

CUTTER

POLISH

SYMMETRY

FLUORESCENCE

INSCRIPTION(S)

1.53 CARAT

D

VVS 2

67.9%

63%

Long

EXCELLENT

EXCELLENT

NONE

IGI LG696530247

COMMENTS: THE LABORATORY GROWN DIAMOND WAS CREATED BY CHEMICAL VAPOR DEPOSITION (CVD) GROWTH PROCESS. TYPE IIA